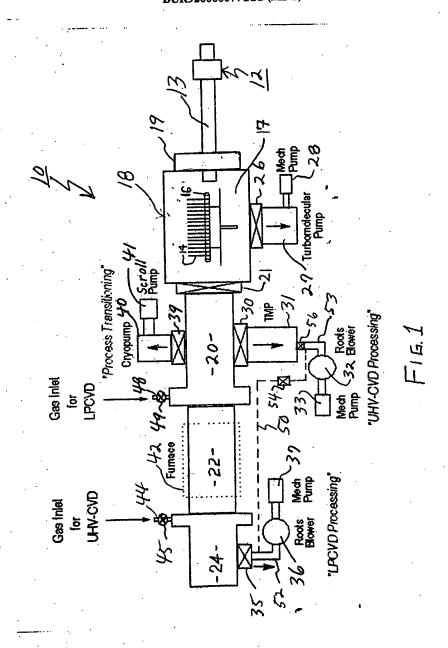
Sheet 1/3 Jack Chu et al. BUR920000077US1 (MFC)



2/3 (BUR920000077US1) "UHV-CVD Processing "LPCVD Processing" Mech Blower "Process Transitioning" Pump Furnace

3/3 (BUR920000077US1)

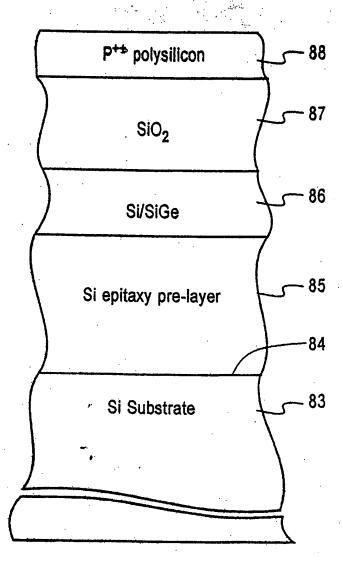


Fig. 3